

## **Supplemental Application Data Sheet**

## Application Information

Application number:: 10/534687  
Filing Date:: 05/12/05  
Application Type:: Regular  
Subject Matter:: Utility  
Suggested Group Art Unit:: N/A  
CD-ROM or CD-R?:: None  
Sequence submission?:: None  
Computer Readable Form (CRF)?:: No  
Title:: ATOMIC LAYER DEPOSITION USING  
METAL AMIDINATES  
Attorney Docket Number:: 0042697.00149US3  
Request for Early Publication?:: No  
Request for Non-Publication?:: No  
Small Entity?:: Yes  
Petition included?:: No  
Secrecy Order in Parent Appl.?:: No

## Applicant Information

Applicant Authority Type::	Inventor
Primary Citizenship Country::	US
Status::	Full Capacity
Given Name::	<u>Roy</u>
Middle Name::	<u>G.</u>
Family Name::	<u>GORDON</u>
City of Residence::	<u>Cambridge</u>
State or Province of Residence::	MA <i>MA</i>
Country of Residence::	US
Street of mailing address::	22 Highland Street
City of mailing address::	Cambridge

State or Province of mailing address:: MA  
 Postal or Zip Code of mailing address:: 02138

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 Applicant Authority Type:: Inventor  
 Status:: Full Capacity  
 Given Name:: Booyong  
 Middle Name:: S.  
 Family Name:: LIM  
 Country of Residence:: US  
 State or Province of mailing address:: MA

#### **Correspondence Information**

Correspondence Customer Number:: 23483

#### **Representative Information**

Representative Customer Number:: 23483

#### **Domestic Priority Information**

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application	371 of	US03/036568	11/14/03
US03/036568	An application claiming the benefit under 35 USC 119(e)	60/426975	11/15/02
US03/036568	An application claiming the benefit under 35 USC 119(e)	60/463365	04/16/03

#### **Foreign Priority Information**

#### **Assignee Information**

Assignee name:: Harvard University